

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Attorney Docket No. 249/258

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BEP
2-1303
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In re patent application of

Yeong-kwan KIM, et al.

Group Art Unit: 2822

Serial No. 09/902,607

Examiner: T. Thomas

Filed: July 12, 2001

For: SEMICONDUCTOR DEVICE HAVING THIN FILM FORMED BY ATOMIC LAYER DEPOSITION AND METHOD FOR FABRICATING THE SAME

PETITION FOR EXTENSION OF TIME
UNDER 37 C.F.R. § 1.136

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

It is respectfully requested that an extension of time for the period indicated below be granted in accordance with the provisions of 37 C.F.R. § 1.136 to take the action required in the application identified in caption, as reflected by the papers submitted herewith.

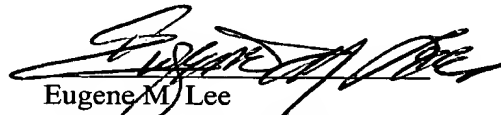
<input checked="" type="checkbox"/> First Month	\$110 (\$ 55)*
<input type="checkbox"/> Second Month	\$300 (\$150)*
<input type="checkbox"/> Third Month	\$520 (\$260)*
<input type="checkbox"/> Fourth Month	\$520 (\$260)*
<input type="checkbox"/> Fifth Month	\$520 (\$260)*

*(Small Entity) TOTAL FEE: \$110.00

The Commissioner is hereby authorized to charge the necessary extension fees to our Deposit Account No. 5-01645.

Respectfully submitted,

February 7, 2003
Date


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